

BAU 1762



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<h1>TRANSMITTAL FORM</h1> <p>(to be used for all correspondence after initial filing)</p>	Application Number	09/854,092	
	Filing Date	May 10, 2001	
	First Named Inventor	Quang, T. P.	
	Group Art Unit	1762	
	Examiner Name	Unknown	
Total Number of Pages in This Submission	5	Attorney Docket Number	PA1663US

ENCLOSURES (check all that apply)		
<input type="checkbox"/> Fee Transmittal Form	<input type="checkbox"/> Assignment Papers (for an Application)	<input type="checkbox"/> After Allowance Communication to Group
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<input type="checkbox"/> Response to Missing Parts/ Incomplete Application	Remarks	
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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
Firm or Individual name	Carr & Ferrell, LLP Cust. No. 22830
Signature	Reg. No. 47,059
Date	August 6, 2001

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#3

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Tony P. Chiang and Karl F. Leeser
SERIAL NO.: 09/854,092
FILED: May 10, 2001
TITLE: Method and Apparatus for Improved Temperature Control
in Atomic Layer Deposition
EXAMINER: Unknown
GROUP ART UNIT: 1762
ATTY.DKT.NO.: PA1663US

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INFORMATION DISCLOSURE STATEMENT
Under 37 C.F.R. §§ 1.56, and 1.97-1.98

SIR:

Pursuant to the provisions of 37 C.F.R. §§ 1.56 and 1.97-98 of the Rules of Practice in Patent Cases, enclosed herewith is a list of co-pending patent applications that may be directed towards similar subject matter. The Examiner is requested to make these references of official record in the application. The references cited may be material to examination of the application and are submitted in compliance with Applicant(s)'s duty of disclosure as defined by 37 C.F.R. § 1.56.




No representation is made or intended as to the completeness of this list, nor is the inclusion of any reference on this list an admission that it is prior art or pertinent to this application.

Respectfully submitted,

Tony P. Chiang, et al.

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Dated: August 6, 2001

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**List of Co-Pending Patent Applications That
May Be Directed Towards Similar Subject Matter**

Examiner's Initials	Serial Number	First-Named Inventor	Title	Filing Date
	09/812,285	Tony P. Chiang	A Sequential Method for Depositing a Film by Modulated Ion-Induced Atomic Layer Deposition (MII-ALD)	03-19-01
	09/812,352	Tony P. Chiang	System and Method for Modulated Ion-Induced Atomic Layer Deposition (MII-ALD)	03-19-01
	09/812,486	Tony P. Chiang	A Continuous Method for Depositing a Film by Modulated Ion-Induced Atomic Layer Deposition (MII-ALD)	03-19-01
Examiner's Signature:				Date